Se	earch No	otes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/720,077	KIM ET AL.
Examiner	Art Unit
Jason Heckert	1746

	SEAR	CHED	
Class	Subclass	Date	Examiner
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner

SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
Updated Search	5/17/2007	JMH